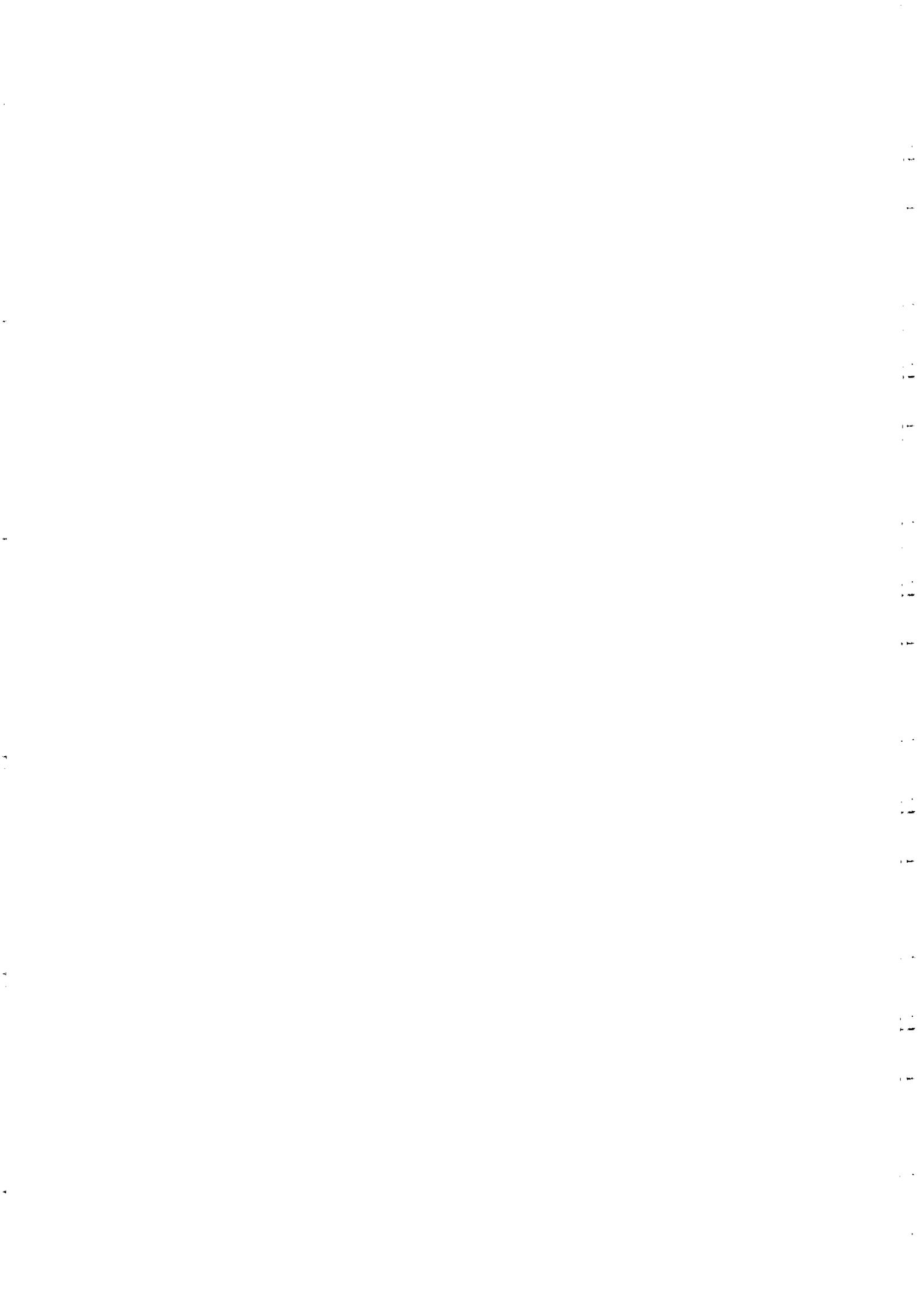


**THIRD WORKSHOP ON
THIN FILMS PHYSICS AND TECHNOLOGY
(8 - 24 MARCH 1999)
including
TOPICAL CONFERENCE ON
MICROSTRUCTURE AND SURFACE MORPHOLOGY
EVOLUTION IN THIN FILMS
(24 - 26 MARCH 1999)**

**"Organic thin films for electronics and photonics"
Part II**

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ITALY**



Film fabrication by O-MBD

- vacuum evaporation in high vacuum (HV) 10^{-7} torr and UHV ($\leq 10^{-10}$ torr)
 - growth rate 0.01 - 1 Å/s
 - several substrates (quartz, silicon, mica, HOPG, ITO, etc)



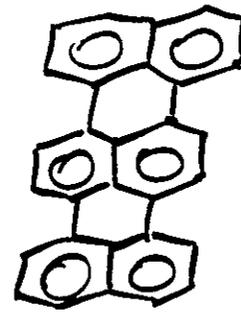
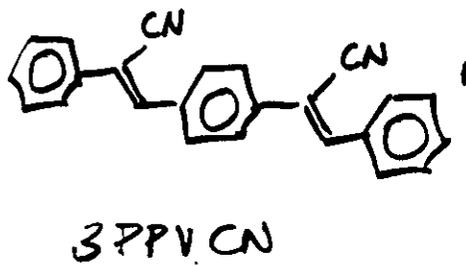
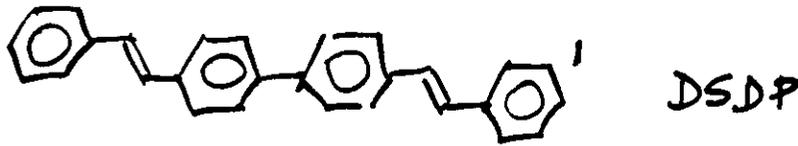
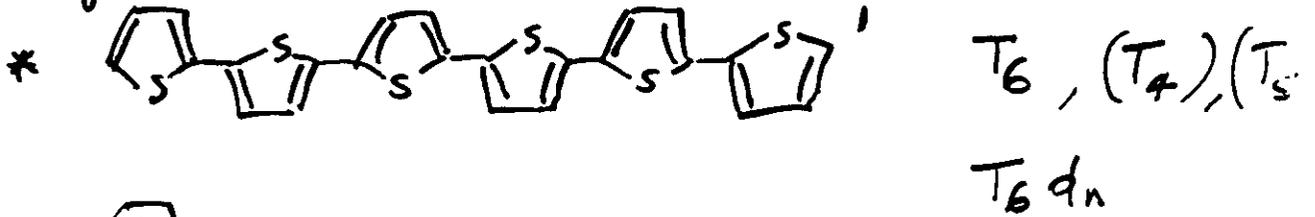
- molecularly ordered thin film
- layer by layer molecular growth

Goals

- control of the quality of:
 - the molecular orientation of the layer
 - definition of the interface
 - thickness of layers
- growth of devices in a clean environment
- characterization of devices "in situ".

Materials

(A) Organics



* Fullerene $C_{60}^{2,5,6}$

terylene

Fullerene $C_{76}^{2,5,1}$

Fullerene C_{82}

* Perylenes $5,6$

Catenanes 3

* Phthalocyanines $4,6$

Rotaxanes 4

* presently loaded in UHV K-cells. (1997)

(B) electrodes Al, Au, Ag

(C) interface SiO_x , fluorinated polymers.

1 TMR SELOA

4 TRM DRUM

2 TMR FULPROP

5 JOULE-T. EUROSCI

3 TMR ENBAC

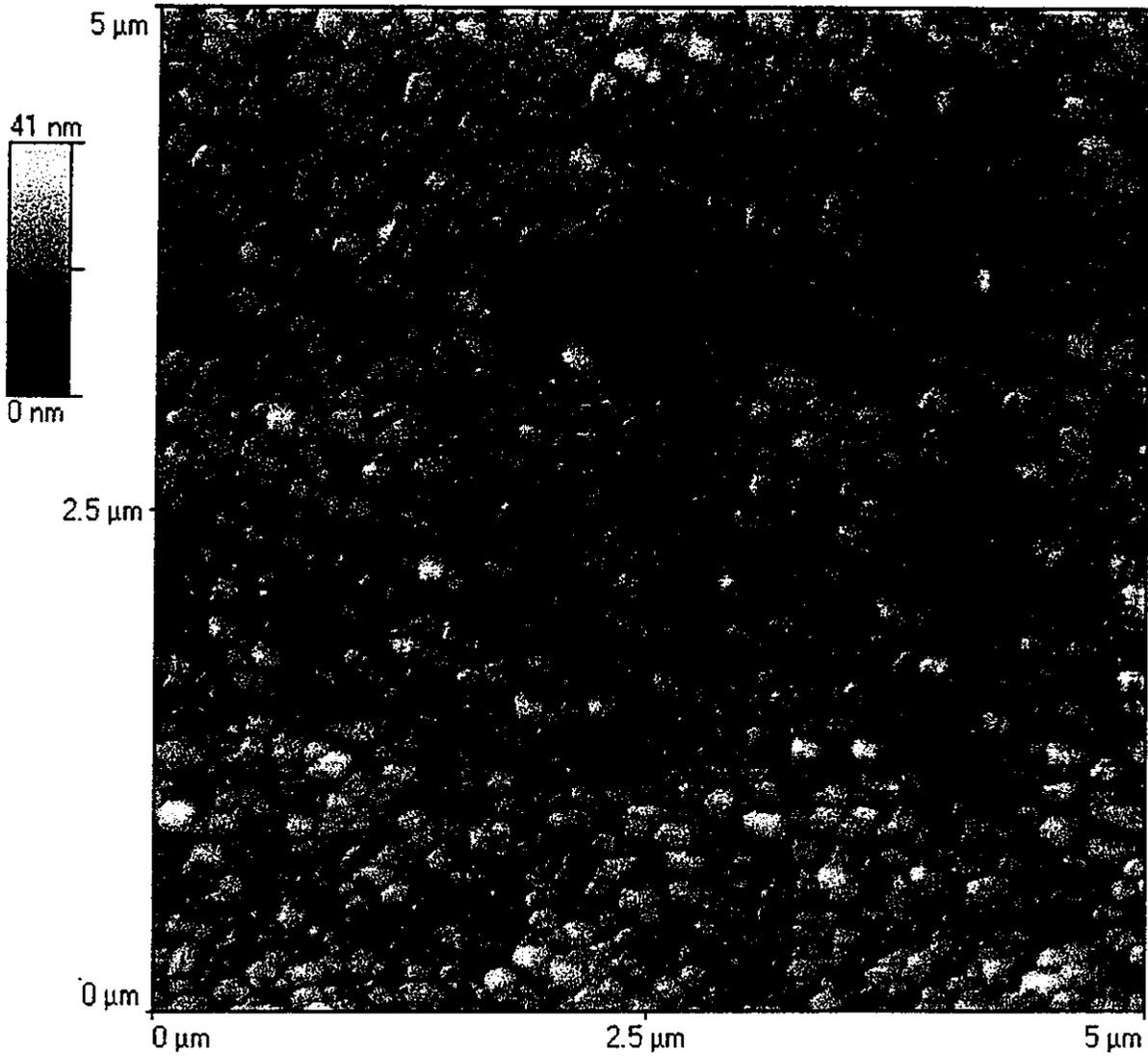
6 BRITF-L MOIALC

- Rigid-Rod Conjugated Organic Semiconductors
 - give rise to ordered thin films by evaporation
 - morphology depends on evap. conditions:
 - substrate material, substrate temperature,
 - base pressure, substrate angle, thickness...
- access to → NEW ARCHITECTURES

□ Processes (→ Devices).

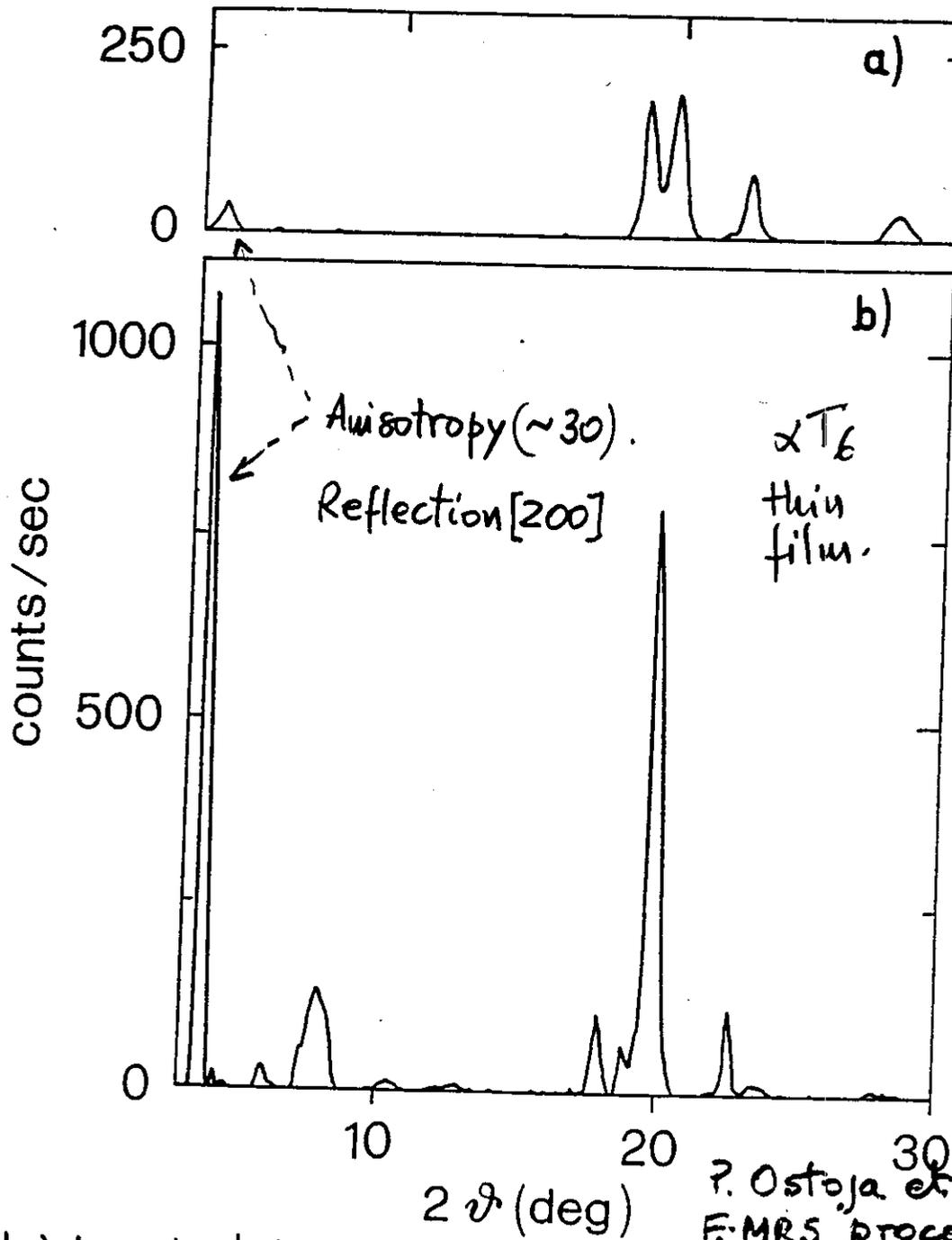
- 1) Charge injection → transport → recombination
 Emission ← Energy transport ← exciton formation
 (Organic LED)
- 2) Photoinduced charge generation → separation
 (Photovoltaic, Photodetectors, SHG) transport
- 3) Photoind. charge gen. + NLO chromophore
 (Photorefractivity) NL response due to Stark effect
- 4) Photoinduced absorption
 (Optical Limiting)

α T_6 Thin Film Typical Morphology



grain diameter 200 ÷ 2000 nm
depending on T_{subr} .

GRAZING INCIDENCE X-RAY DIFFRACTION



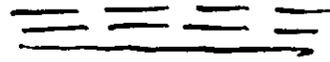
- very high orientation - grain size ~ 30 nm.
- no appreciable amorphous phase.

X-ray diffraction patterns taken on an evaporated α -sexithienyl film at 0.5 deg grazing incidence (a) and symmetric Bragg-Brentano geometry (b). Note the anisotropy of the relative peak intensities in the two patterns.

⇒ Rigid-rod conjugated organic semiconductors



insulating substrate



metallic

⇒ Spherical conjugated semicon. fullerenes

face centered cubic

Processes

charge injection
transport
recombination

exciton formation
transport
emission

charge generation
separation
transport

non-linear opt. response

excited state absorption

Devices

OLED

Photovoltaic

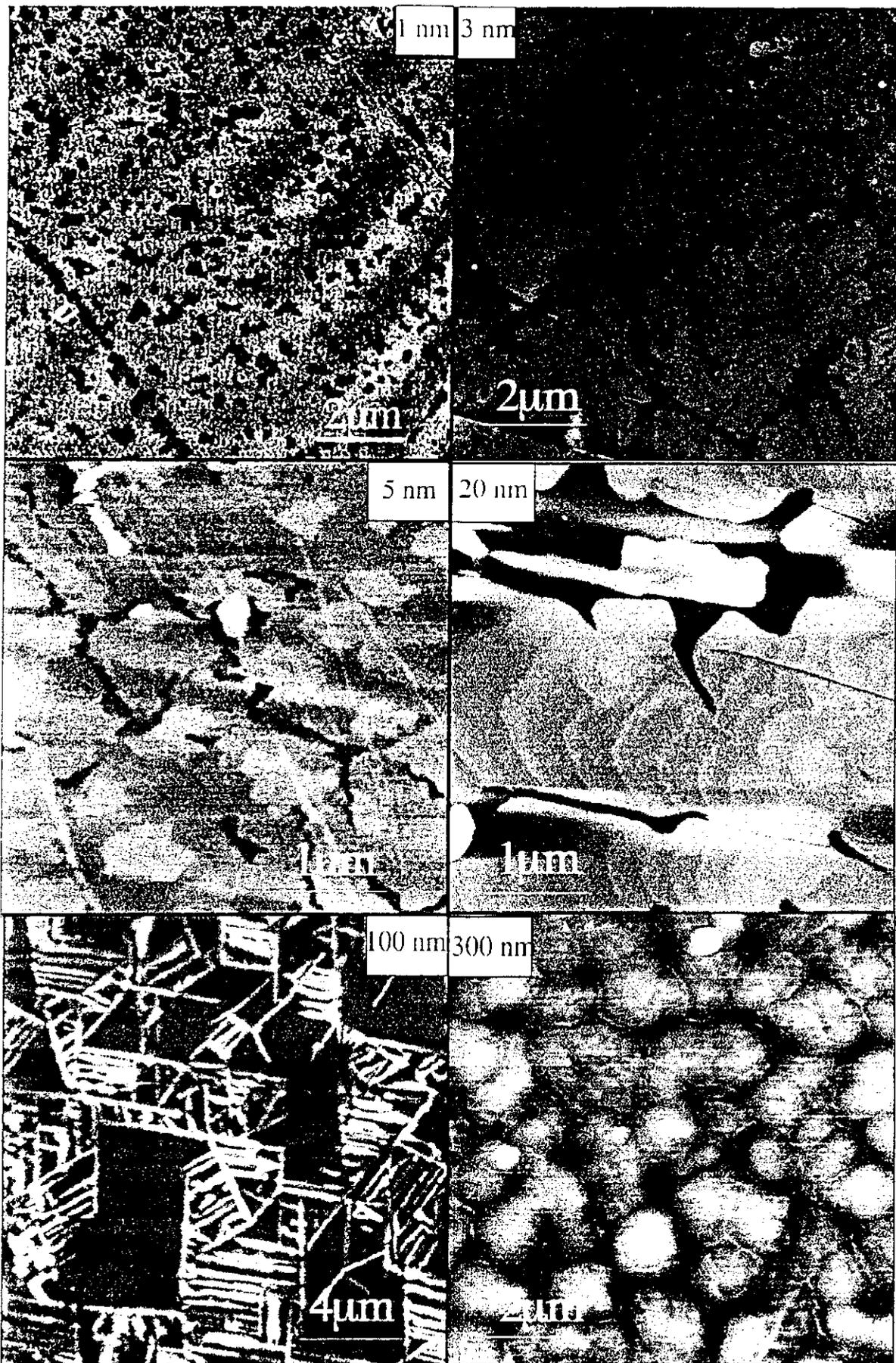
Photorefractivity

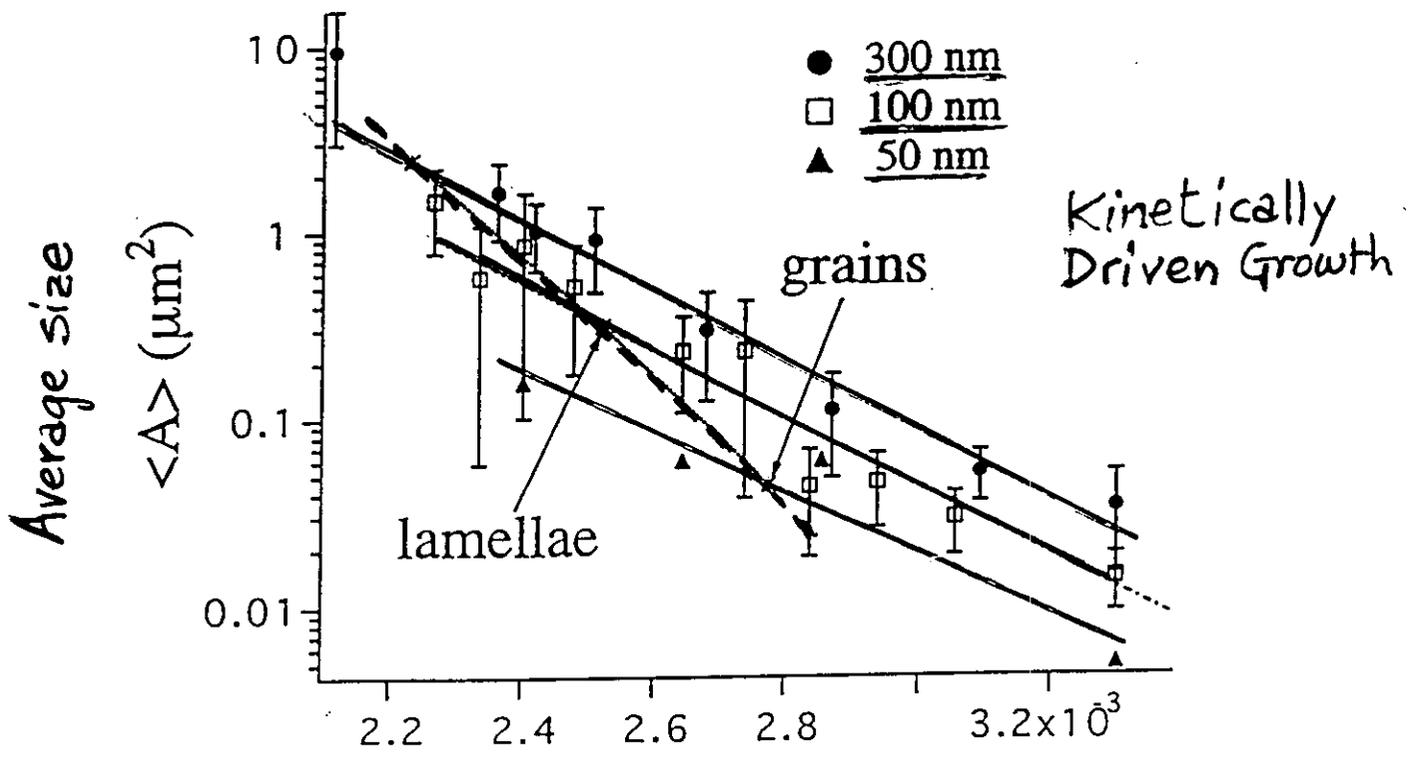
Optical limiting



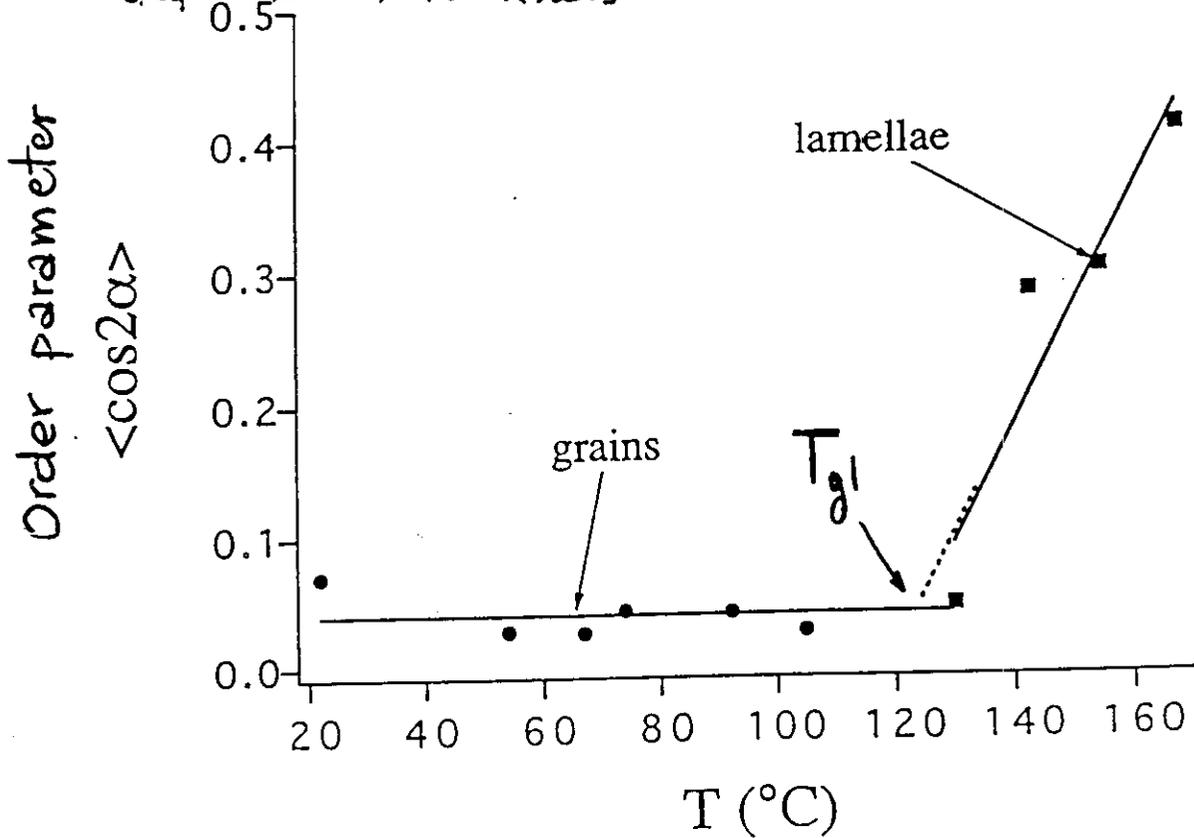
$T_{sub} = 150^{\circ}C$

αT_6 on mica





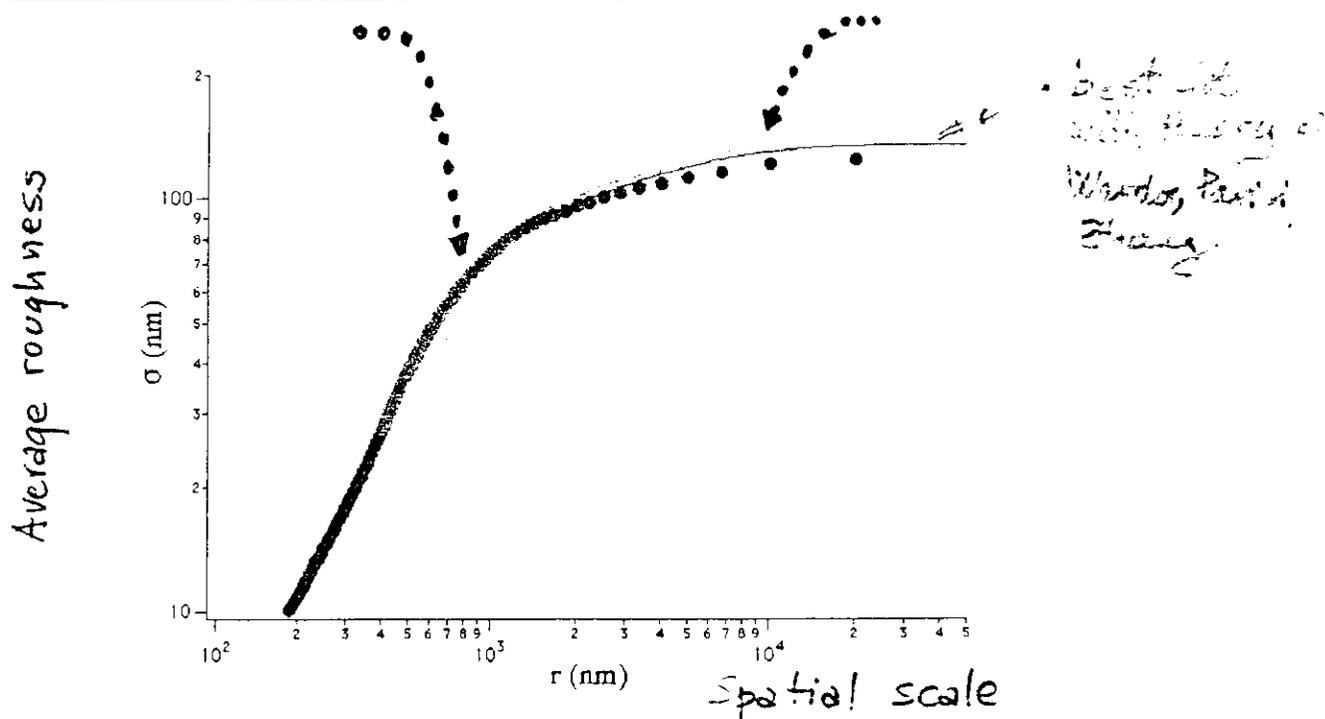
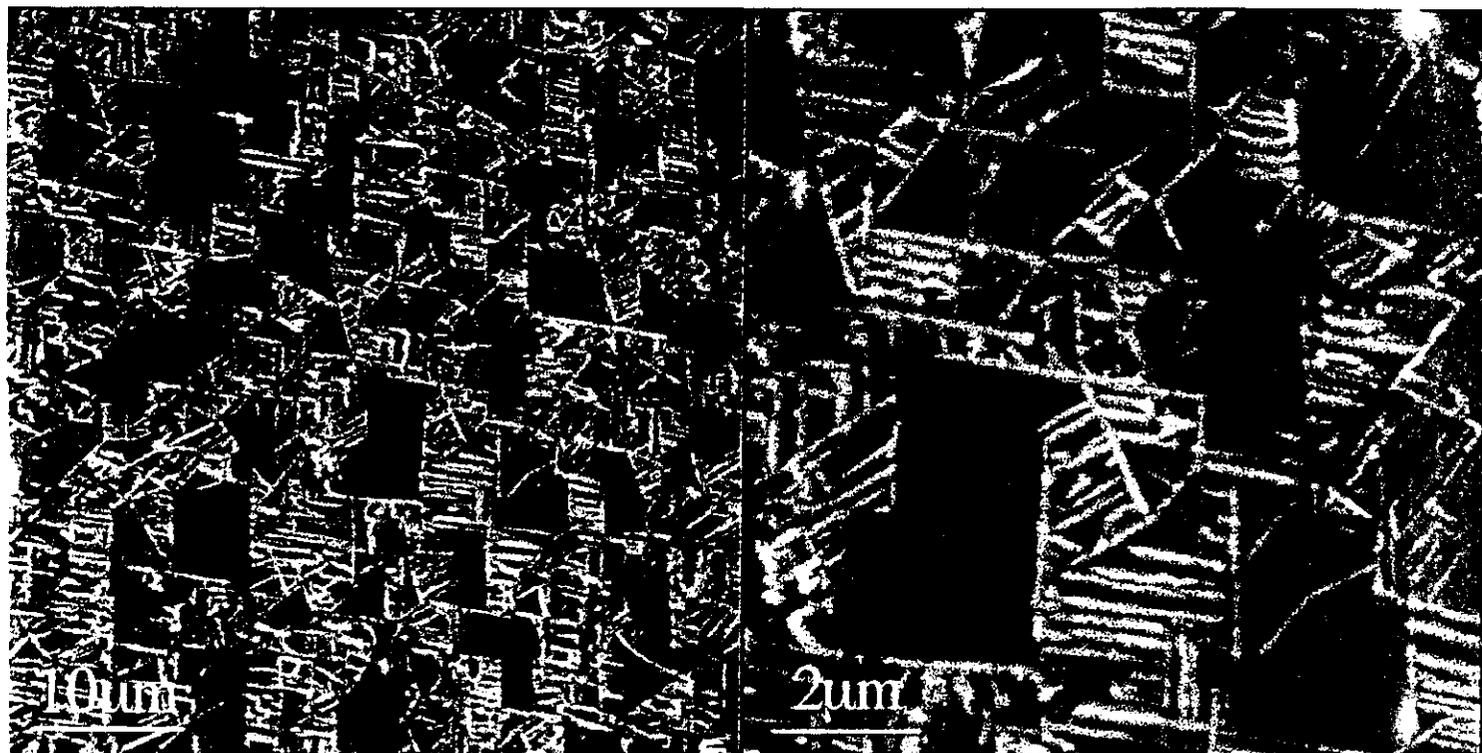
- Arrhenius plot $1/T$ (K^{-1}) small Δ larger grains
- grain \rightarrow lamellae transition depends on thickness depends on thickness



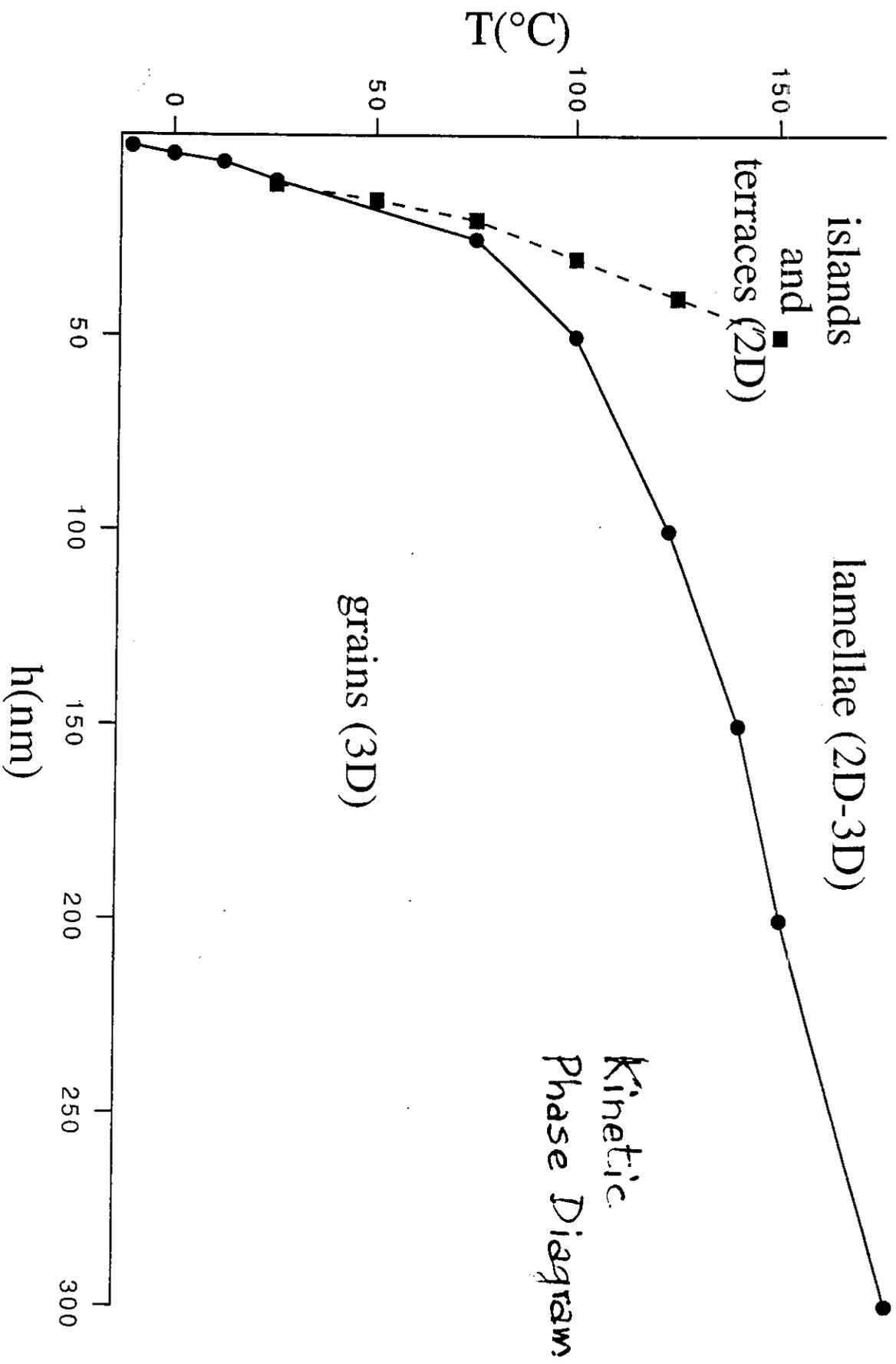
- Orientational ordering transition @ $T_{g'}$

F. Biscarini et al. Phys. Rev. B. 95, 52, 14868.

Roughness scaling properties

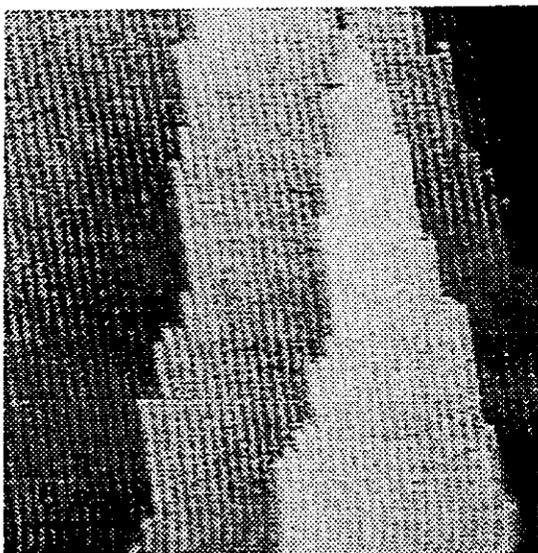


F. Biscarini et al. Phys. Rev. Lett. 78, 2389 (97)

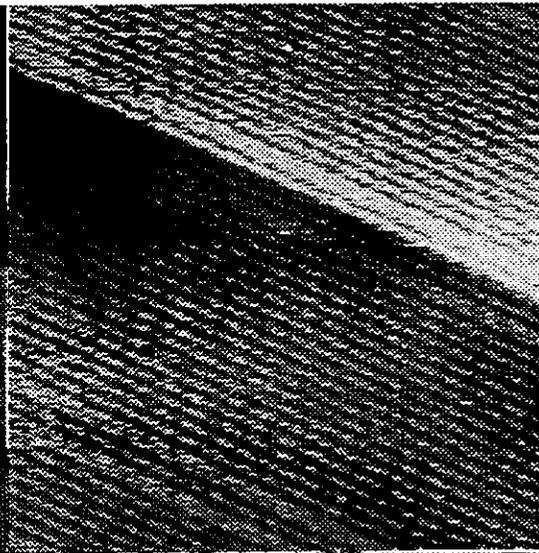


T6 on Au (110) - 1x2 reconstructed

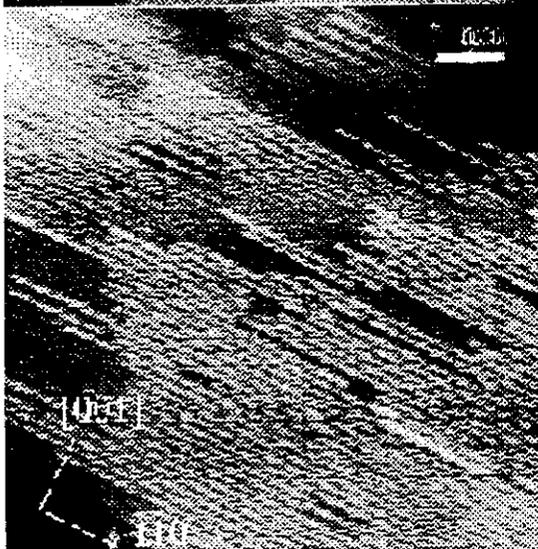
0 ML



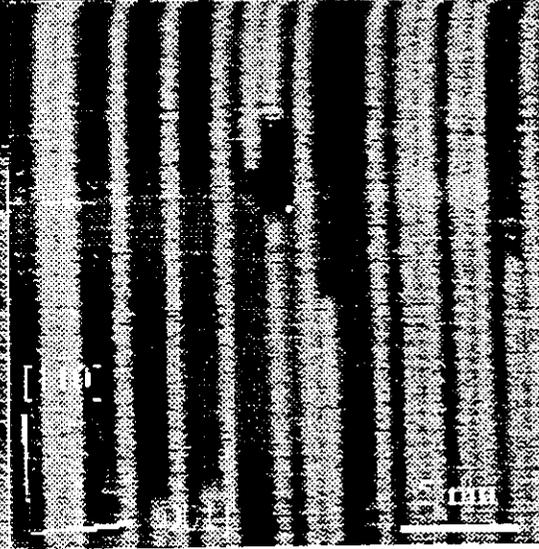
~0.6 ML

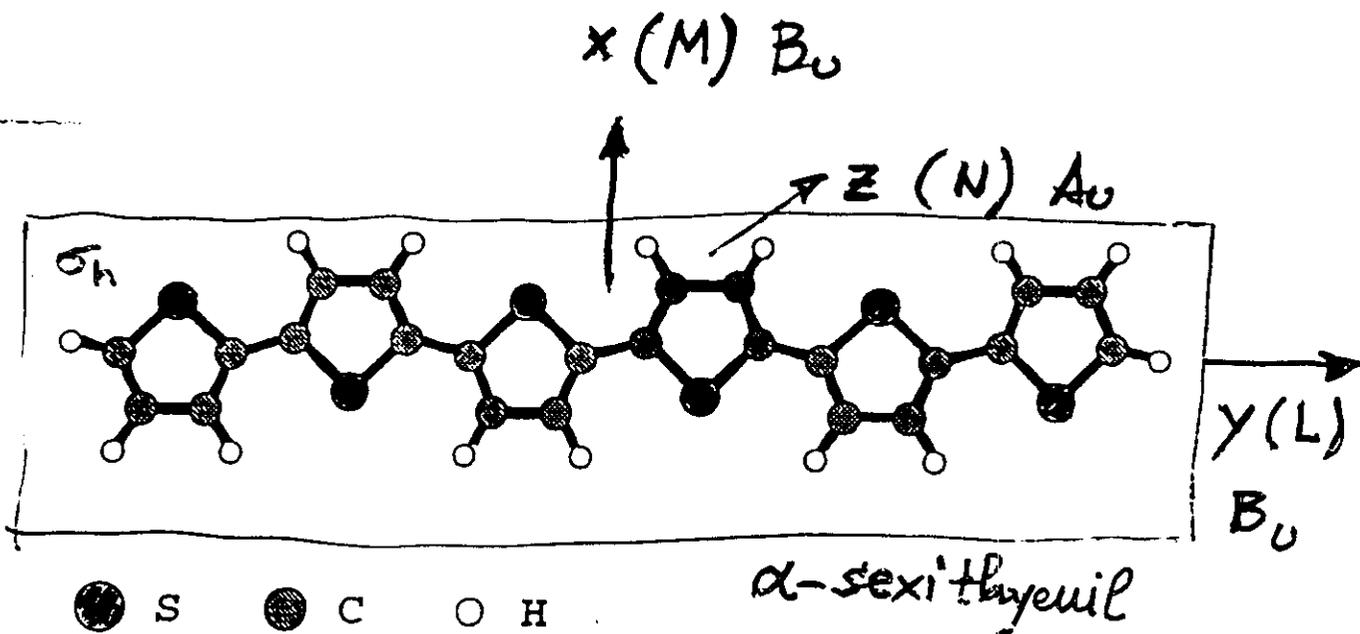


~1 ML



~2 ML





C_{2h}	E	C_2	i	σ_h		
A_g	1	1	1	1	R_z	$\alpha_{xx}, \alpha_{yy}, \alpha_{zz}, \alpha_{xy}$
B_g	1	-1	1	-1	R_x, R_y	α_{yz}, α_{zz}
A_u	1	1	-1	-1	T_z	} dipole allowed transitions.
B_u	1	-1	-1	1	T_x, T_y	

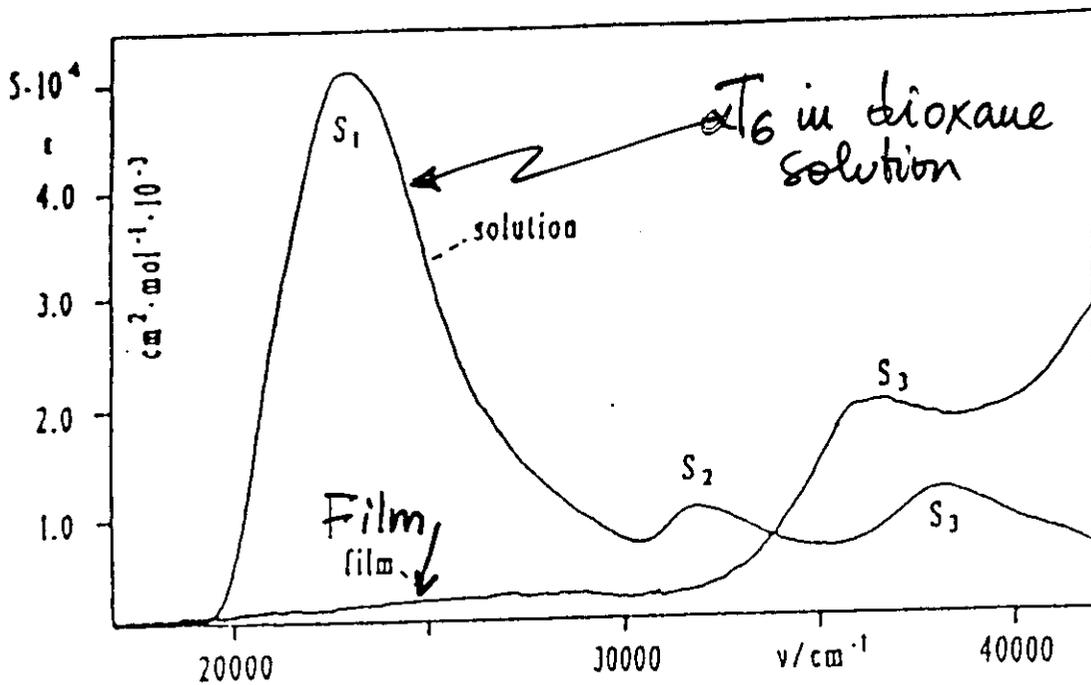


Fig. 3. Absorption spectra of 6T in solution (dioxane) and in a 2.2 nm film vapour deposited onto fused silica (surface normal parallel to incident beam). (D. Odian et al.)

R. Colditz et al.
Chem. Phys. 201, 309 (95)

5T		6T	
ΔE (eV)	symmetry	ΔE (eV)	symmetry
2.53	1^1B_2	2.45	1^1B_u
3.35	2^1A_1	3.12	2^1A_g
3.64	3^1A_1	3.57	3^1A_g
3.93	2^1B_2	3.71	2^1B_u
4.33	4^1A_1	4.05	3^1B_u
4.34	3^1B_2	4.13	4^1A_g
4.82	5^1A_1	4.44	4^1B_u
4.84	4^1B_2	4.62	5^1A_g
4.91	6^1A_1	4.65	5^1B_u
4.92	5^1B_2	4.85	6^1B_u

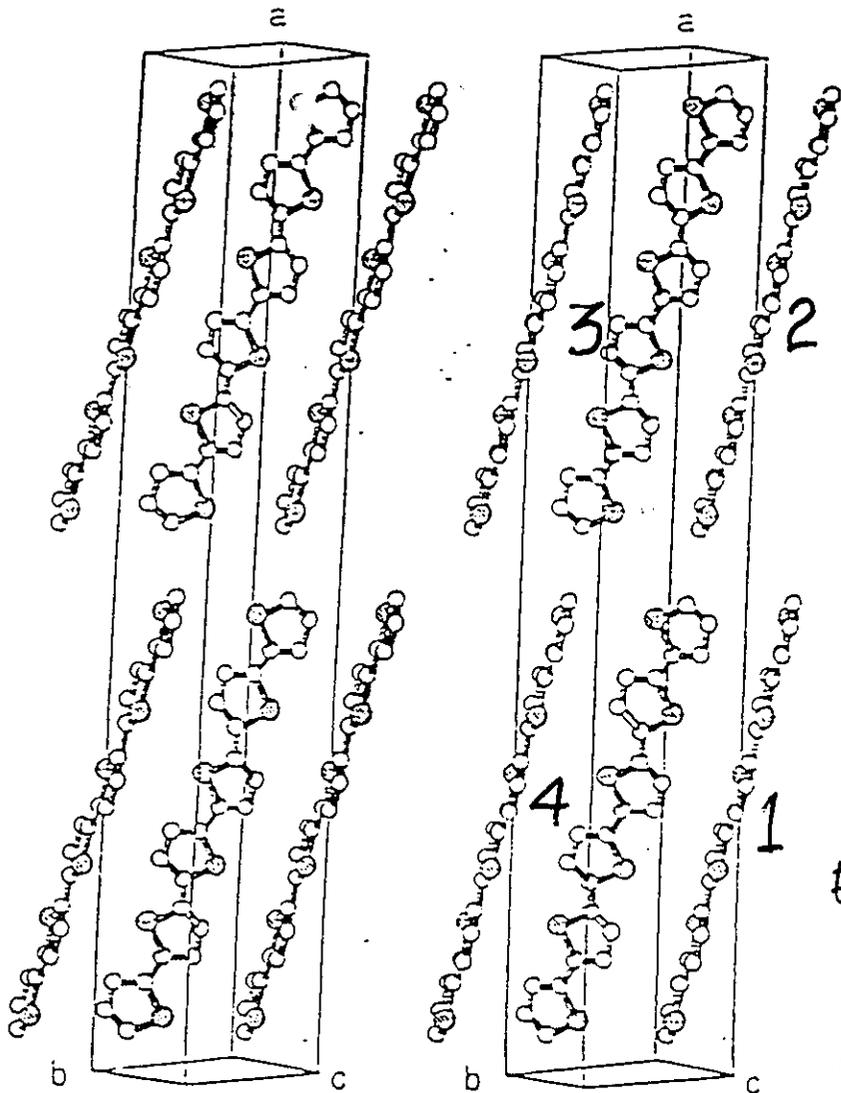
L axis
M axis

↑↑

J. Beljonne et al. $T_1 \rightarrow T_n$ energies, calculated on the basis of the ground-state geometries of oligothiophenes. Experimental data taken from optical measurements in solution are also included. All the energies are given in eV.

↓↓

	Th2	Th3	Th4	Th5	Th6	Th7	Th9	Th11
$S_0 \rightarrow S_1$ Calc.	4.23	3.58	3.16	2.92	2.72			
Exp.	4.12 ^a	3.49 ^a	3.18 ^a	3.00 ^a	2.72 ^b	2.58 ^b	2.45 ^b	2.40 ^b
$T_1 \rightarrow T_n$ Calc.	4.37	3.42	3.01	2.62	2.40			
Exp.		2.70 ^c	2.21 ^c		1.75 ^b	1.60 ^b	1.52 ^b	1.45 ^b
$S_0 \rightarrow T_1$ Calc.	1.84	1.68	1.61	1.61	1.65			
Exp.		1.74 ^d						



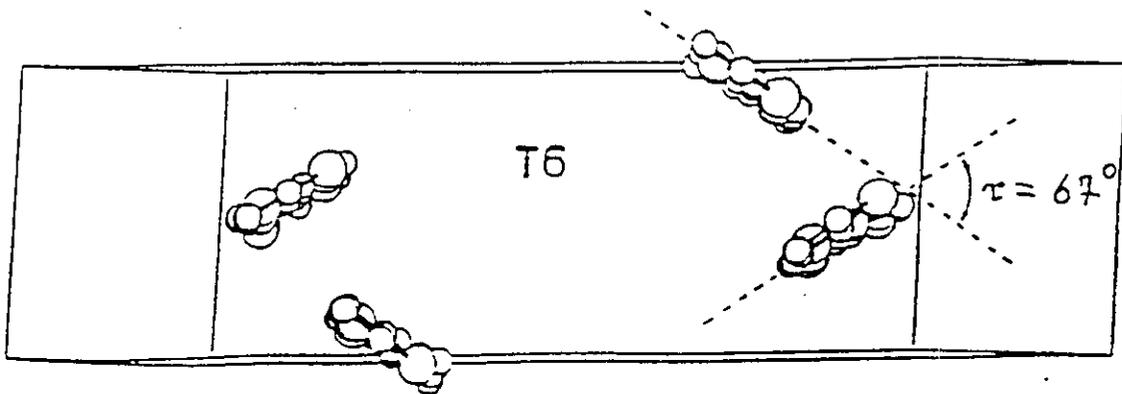
crystal system	monoclinic
space group	$P2_1/n$
Z	4
a (Å)	44.708
b (Å)	7.851
c (Å)	6.029
α (deg)	90.0
β (deg)	90.76
γ (deg)	90.0

$$E(1) = 1$$

$$i(1) = 2$$

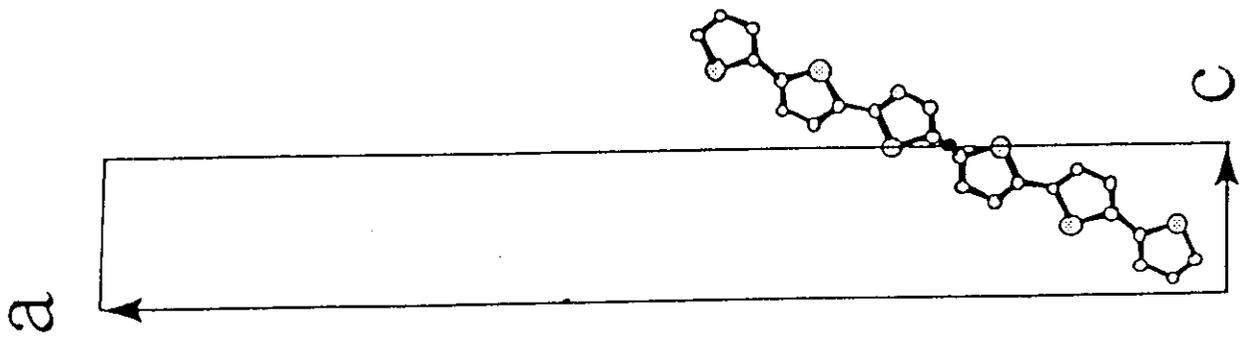
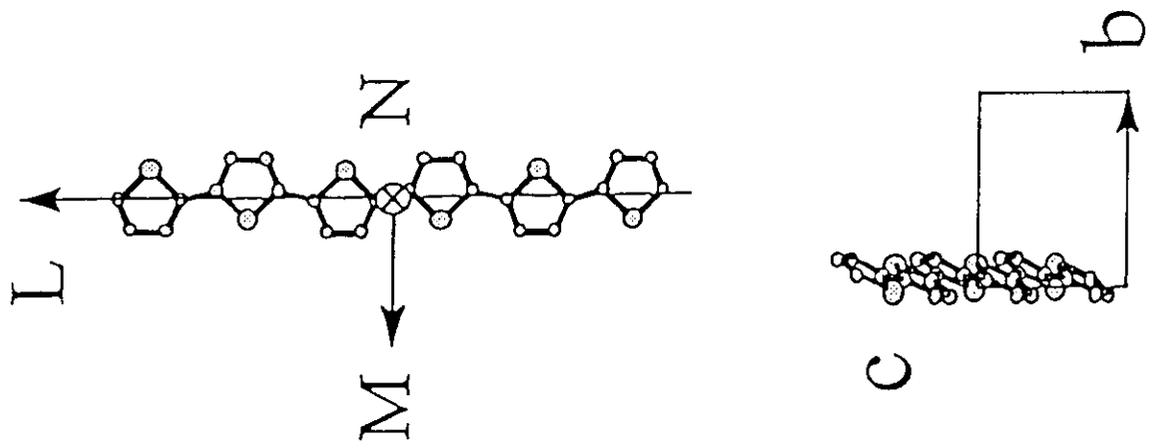
$$\sigma_h(1) = +$$

$$C_2(1) = 3$$



G. Horowitz et al. *Chem. Mat.* 7 (1995) 1337

W. Porzio et al. *Acta Polymer.* 44 (1993) 266.



Correlation of Excited Electronic States of αT_6

Free Molecule \xleftarrow{u} \xrightarrow{u} Crystal

Molecular symmetry C_{2h}	Site symmetry C_1	Factor group symmetry C_{2h}
A_g B_g $(N) A_u$ <u>$(L, M) B_u$</u>	A	a_g b_g <u>$a_u(b)$</u> <u>$b_u(ac)$</u>

$$E_{ag}(k=0) = E_0 - D + I_{11} + I_{12} + I_{13} + I_{14}$$

$$E_{bg}(k=0) = E_0 - D + \quad + \quad - \quad -$$

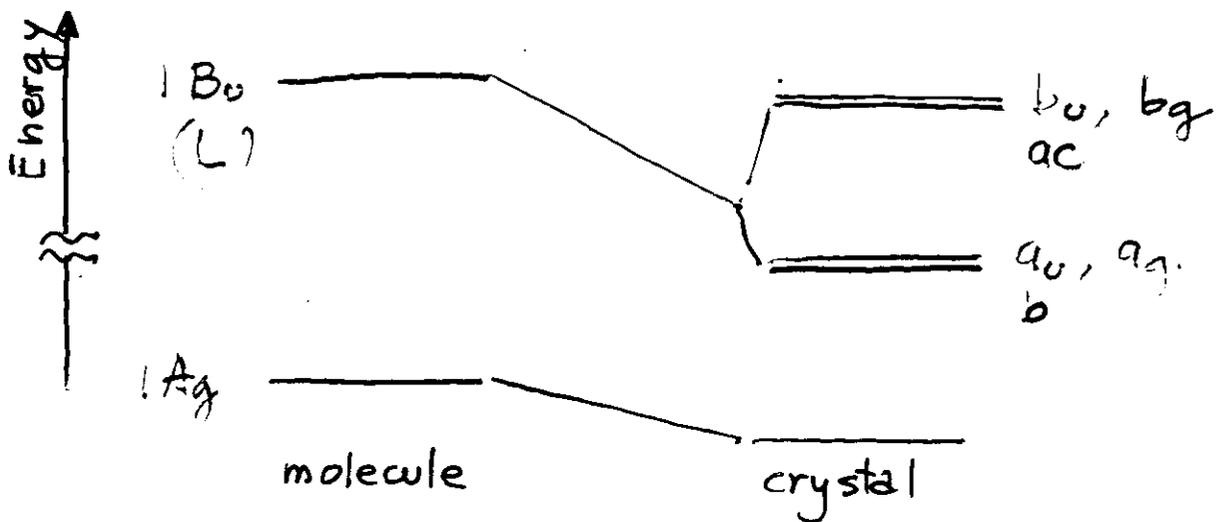
$$E_{av}(k=0) = E_0 - D + \quad - \quad - \quad +$$

$$E_{bv}(k=0) = E_0 - D + \quad - \quad + \quad -$$

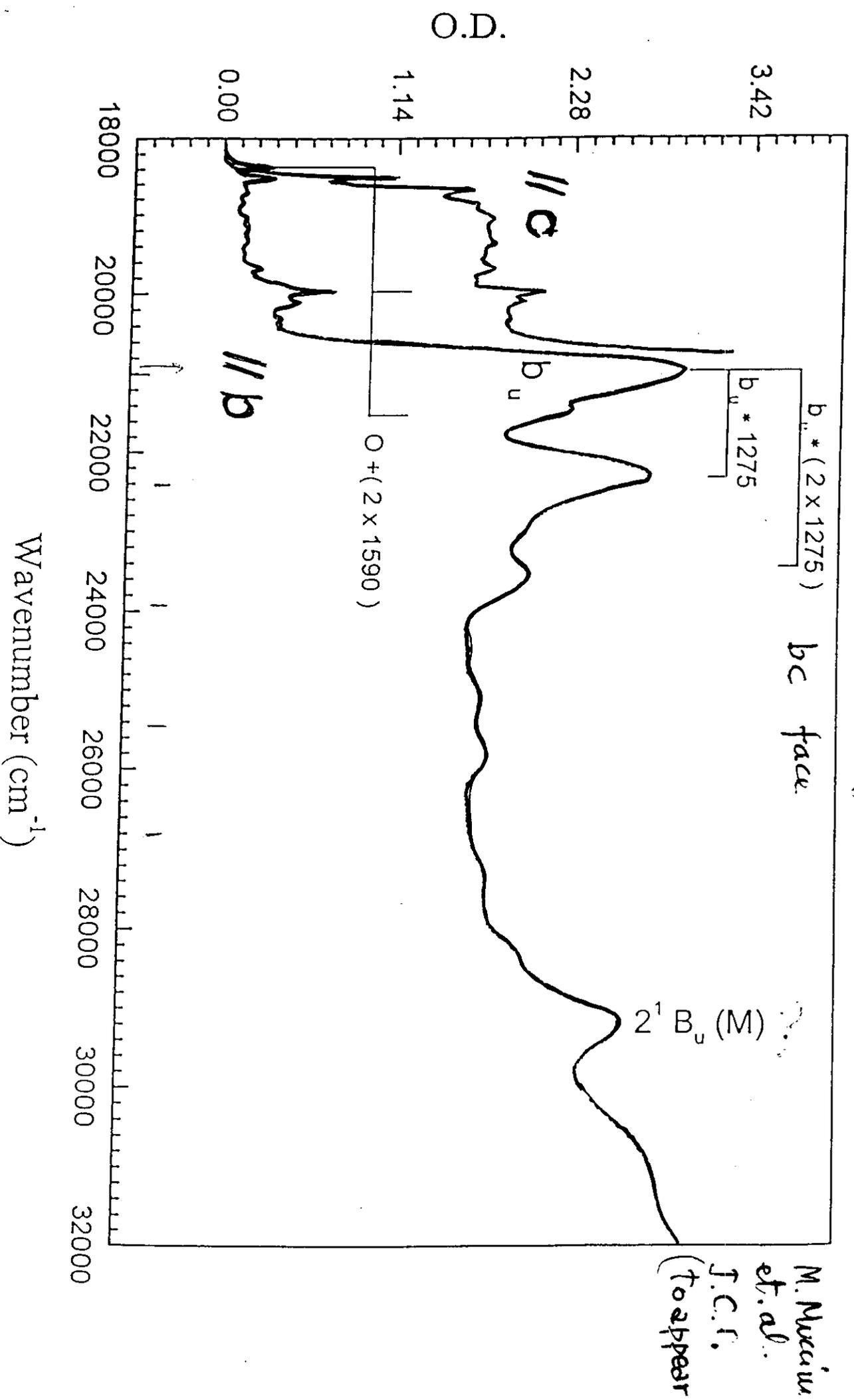
E_0 = electronic energy of the free molecule

D = difference of stabilization E in the excited and in the ground state Crystal Shift

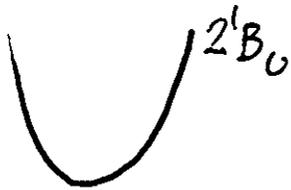
$$I_{ij} = \sum_{n \neq m} \{ \varphi_n^* \varphi_m | V_{nm} | \varphi_n \varphi_m^* \} \quad \text{Resonance Integrals}$$



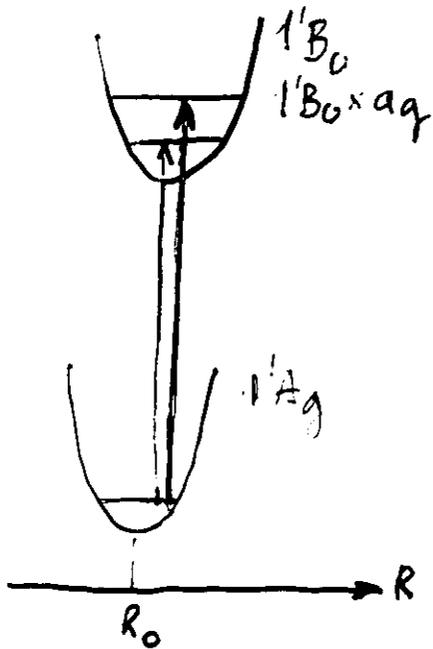
α Ti₆ single crystal pol. absorption at 4.2K



Herzberg-Teller coupling
in αT_6 - A special case



a_g modes couple 1^1B_0 with 2^1B_0



$$\text{---} \langle 1^1A_g | \mu_y | 1^1B_0 \rangle$$

$$\text{---} \langle 1^1A_g | \mu_y | 1^1B_0 a_g \rangle$$

+

Frauck-Coulson

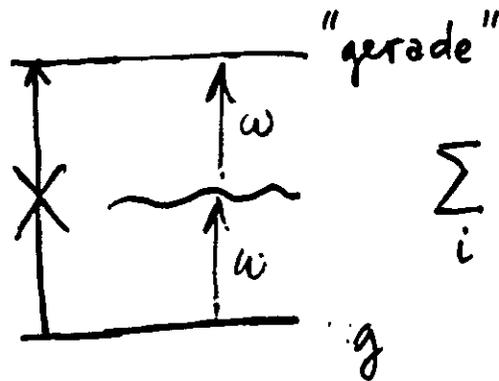
→ vibrational wf overlap $\langle 0 | a_g \rangle$
FC

Herzberg-Teller

→ borrowing intensity from higher 2^1B_0 state.

$$\xrightarrow{\text{HT}} \langle 1^1A_g | \mu_y | 1^1B_0 a_g \rangle = \sum_{\substack{n^1B_0 \\ (n \neq 1)}} \frac{\langle 1^1A_g | \mu_x | n^1B_0 \rangle}{\Delta E_{(n^1B_0 - 1^1B_0)}}$$

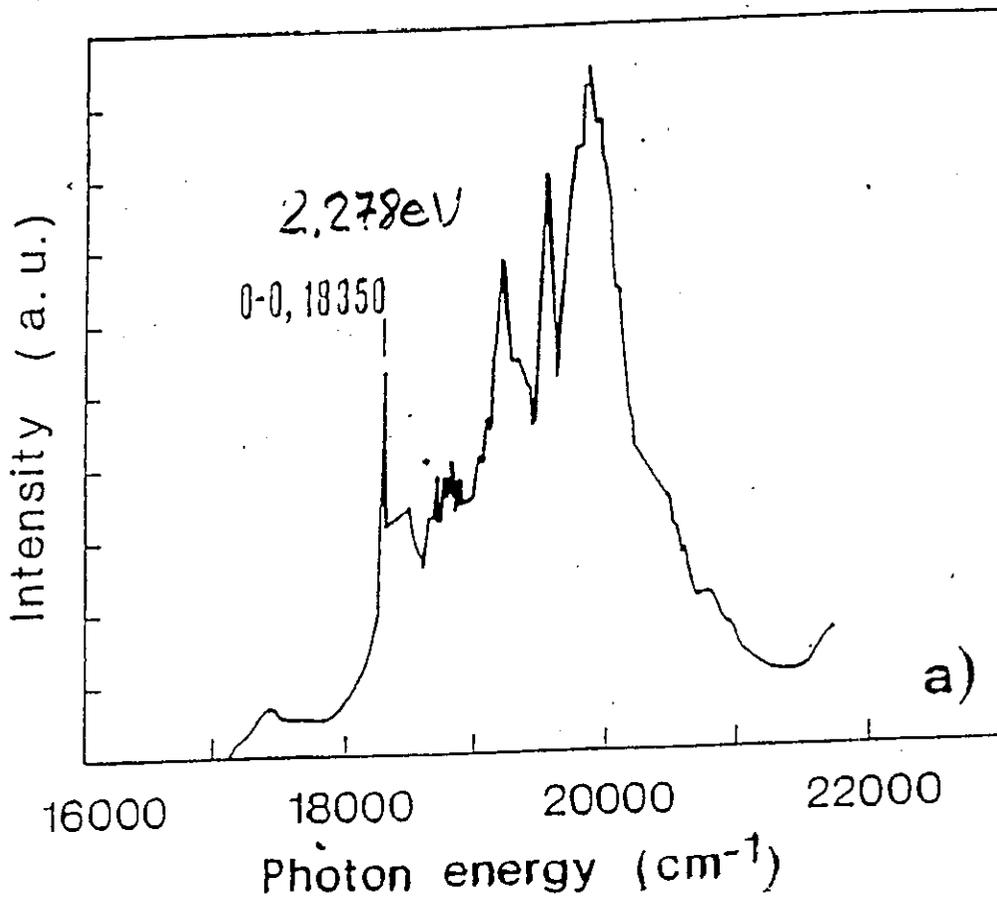
Two-photon absorption



$$\sum_i \frac{\langle g | e r_1 | u_i \rangle \langle u_i | e r_2 | g' \rangle}{E_i - \omega} \neq 0$$

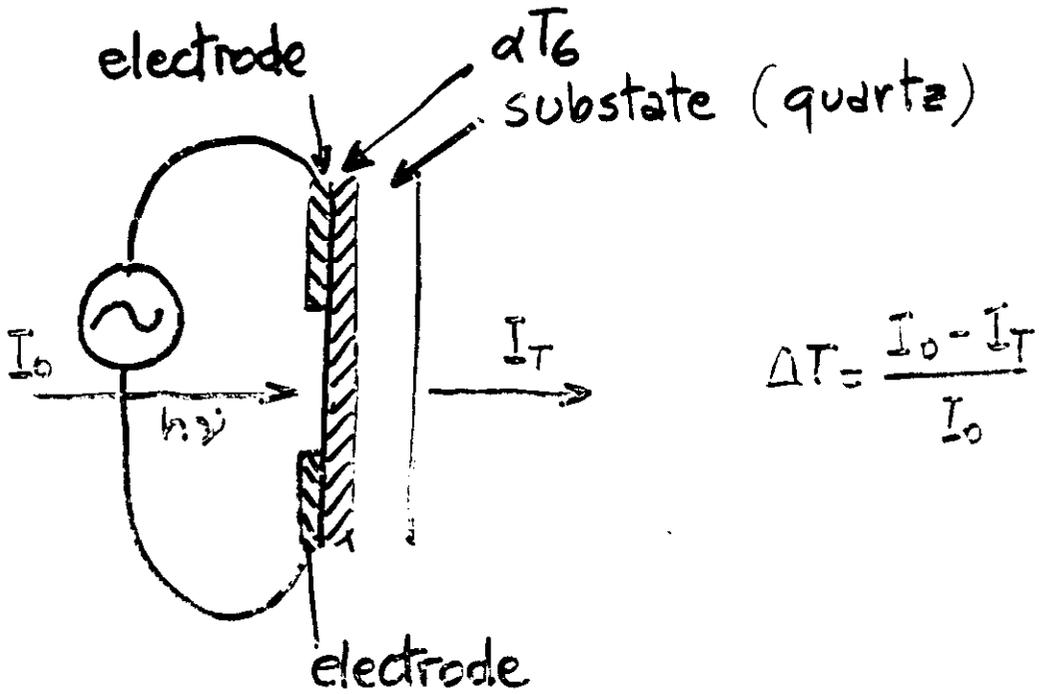
$$g \otimes u \otimes g \neq g$$

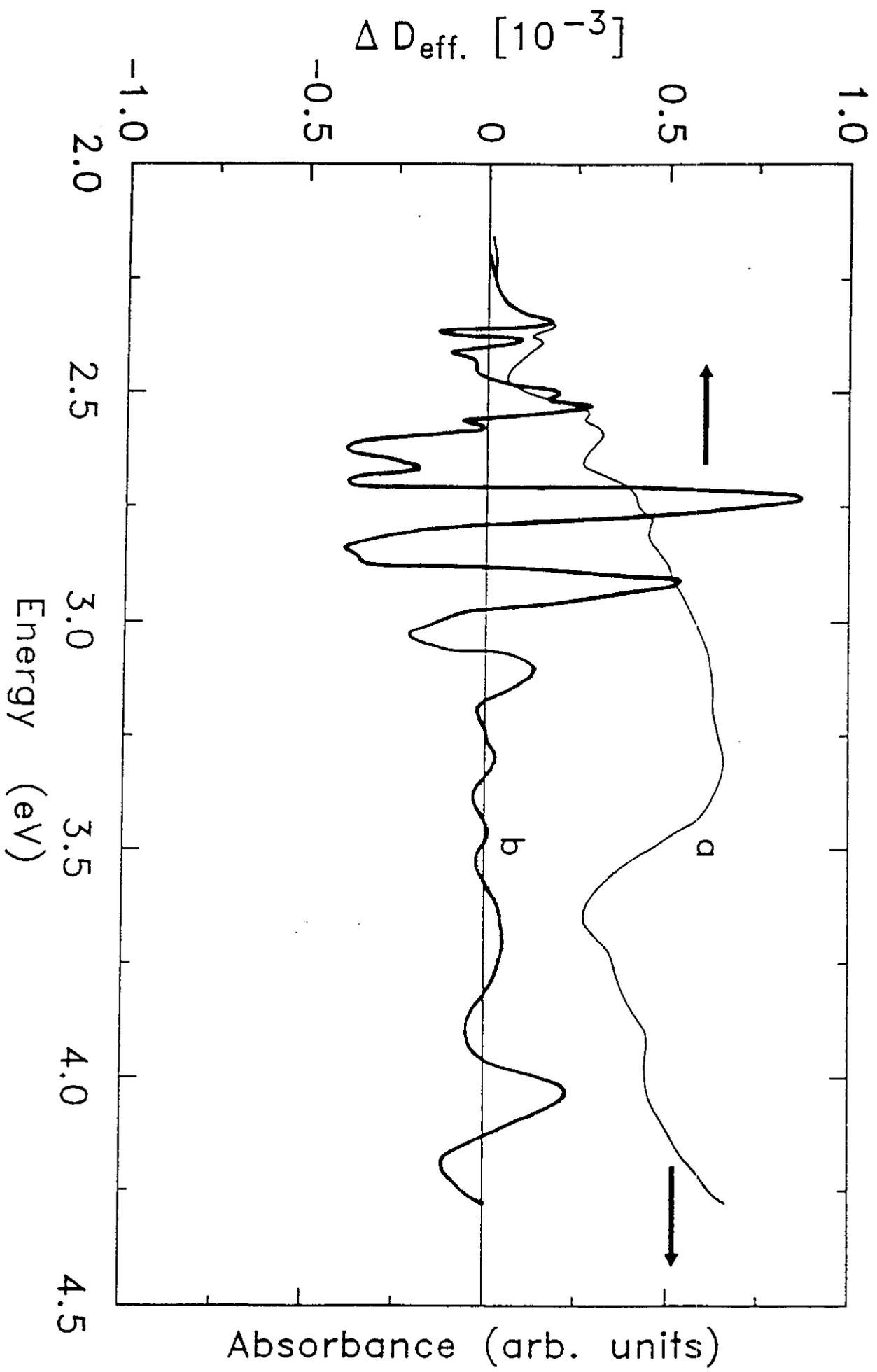
$$g \otimes u \otimes u = g$$



N. Periasamy, R. Danieli, G. Ruani, R. Zamboni,
and C. Taliani, Phys. Rev. Lett., **68** (1992) 919

Electroabsorption





Stark Shift

$$\Delta E = \Delta \mu F + \frac{1}{2} \Delta \alpha F^2 \quad F = \text{el. field}$$

dip. mom. $\Delta \mu = \mu_e - \mu_g$ excited state
ground "

polariz.: $\Delta \alpha = \alpha_e - \alpha_g$

→ For neutral excitations (Frenkel) $\Delta \mu = 0 \Rightarrow \Delta E \propto F^2$

→ " charged " (CTE, → CB) $\Delta \mu \neq 0 \Rightarrow \Delta E \propto F$

$$\left(\frac{\Delta I}{I} \right) = \frac{1}{\sqrt{2}} F_{\text{eff}}^2 \left(\frac{\Delta \alpha}{2hc} \frac{\partial D}{\partial r} + \frac{\Delta \mu^2}{10hc^2} \frac{\partial^2 D}{\partial r^2} \right) \quad (\text{from Liptay})$$

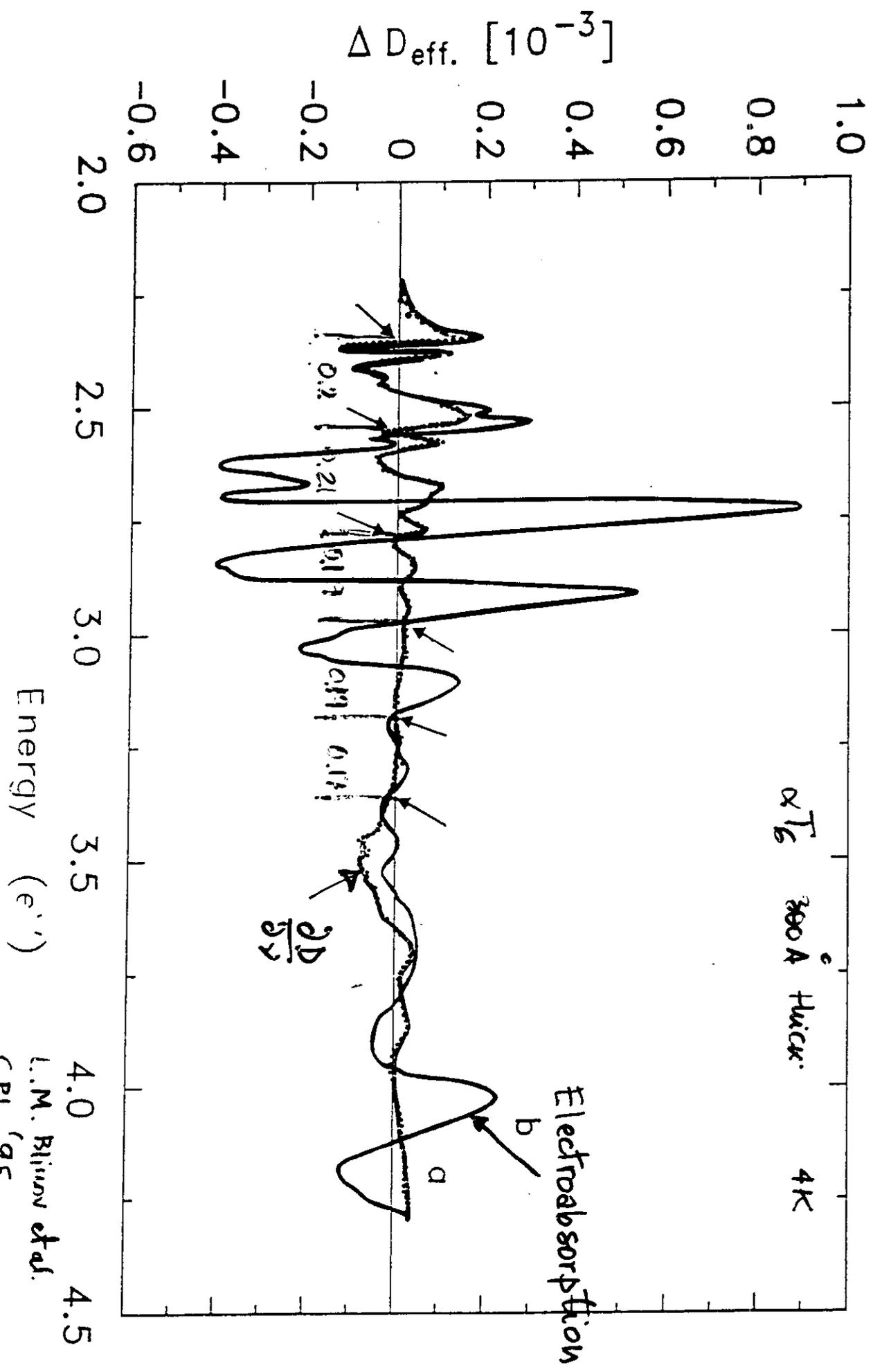
⇨ for Frenkel excitons ≈ 0

i.e.

$$\frac{\Delta I}{I} = \frac{1}{\sqrt{2}} F_{\text{eff}}^2 \frac{\Delta \alpha}{2hc} \frac{\partial D}{\partial r}$$

⇨ for Charge transfer excitons

$$\frac{\Delta I}{I} \sim A \frac{\partial D}{\partial r} + B \frac{\partial^2 D}{\partial r^2}$$



L.M. Blinov et al.
CPL '95